Amendments to the Specification:

Please replace the title as follows:

COMPOSITION FOR THIN FILM CAPACITANCE ELEMENT, INSULATING FILM OF
HIGH DIELECTRIC CONSTANT, THIN FILM CAPACITANCE ELEMENT, THIN FILM
LAMINATED CAPACITOR AND METHOD FOR MANUFACTURING THIN FILM
CAPACITANCE ELEMENT

THIN FILM CAPACITANCE ELEMENT COMPOSITION, HIGH PERMITTIVITY

INSULATION FILM, THIN FILM CAPACITANCE ELEMENT, THIN FILM

MULTILAYER CAPACITOR AND PRODUCTION METHOD OF THIN FILM

CAPACITANCE ELEMENT